



PATENT APPLICATION

RCE  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takaaki NODA et al.

Group Art Unit: 1792

Application No.: 10/587,500

Examiner: K. STOUFFER

Filed: July 27, 2006

Docket No.: 128807

For: METHOD OF MANUFACTURING  
SEMICONDUCTOR DEVICE AND  
APPARATUS FOR PROCESSING  
SUBSTRATE

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

☒ Applicants further request entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 216010 in the amount of ☒ \$810.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

Samuel T. Dangremond  
Registration No. 60,466

JAO:STD/emd

Date: March 6, 2009

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DEPOSIT ACCOUNT USE  
AUTHORIZATION  
Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461

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